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CONFIRMATION NO. 7419

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| SERIAL NUMBER 10/702,049 | FILING OR 371(c) DATE 11/06/2003 RULE | CLASS 427 | GROUP ART UNIT 1792 | ATTORNEY DOCKET NO. FIS920060073US1 (RAJ-014) |
| APPLICANTS Noriaki Fukiage, Hartsdale, NY; Katherina Babich, Chappaqua, NY; | | | | |
| ** CONTINUING DATA ***** <i>none</i> | | | | |
| ** FOREIGN APPLICATIONS ***** <i>none</i> | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED <i>T.T</i> ** 02/13/2004 | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <i>Allowance</i> Verified and Acknowledged <i>T.T</i> Examiner's Signature Initials | | STATE OR COUNTRY NY | SHEETS DRAWING 4 | TOTAL CLAIMS 43 |
| | | | | INDEPENDENT CLAIMS 1 |
| ADDRESS James Klekotka Suite 10 4350 W. Chandler Blvd. Chandler, AZ85226 | | | | |
| TITLE Method of improving post-develop photoresist profile on a deposited dielectric film | | | | |
| FILING FEE RECEIVED 1314 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |